PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Akinori KOUKITSU et al. Group Art Unit: 1722

Application No.: 10/509,177 Examiner: M. SONG

Filed: September 27, 2004 Docket No.: 121213

For: VAPOR PHASE GROWTH METHOD FOR

A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING A1-CONTAINING III-V GROUP COMPOUND

SEMICONDUCTOR

MAIL STOP RCE

LARGE ENTITY REQUEST FOR CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination

Applicants further request entry and consideration of the submission filed August 16, 2007.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

The fees associated with this filing are being paid electronically with this filing. The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

James A. Oliff Registration No. 27,075

Brian C. Anscomb Registration No. 48,641

IAO:BCA/ray

Date: September 18, 2007

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Alexandria, Virginia 22320 Telephone: (703) 836-6400 DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461